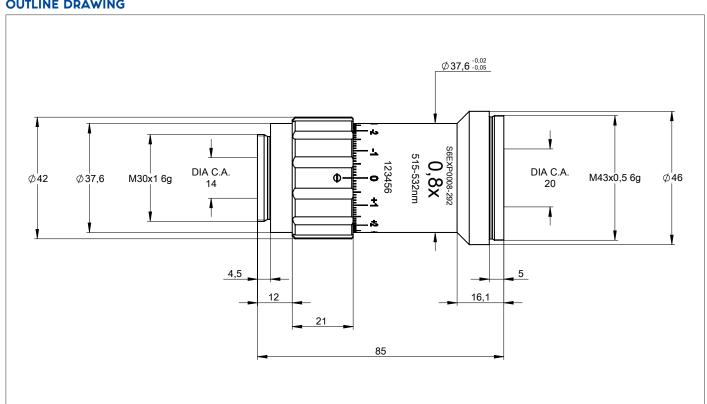
## DATA SHEET

### S6EXPOO08-292

**BEAMEXPANDER MAGNIFICATION 0.8** FOR 515 - 545 nm **FUSED SILICA** 



#### **OUTLINE DRAWING**



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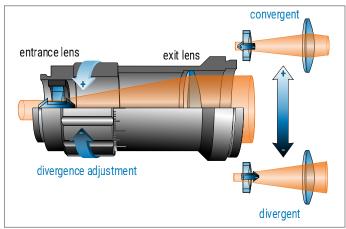


# DATA SHEET

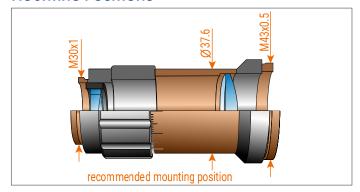
#### **SPECIFICATIONS**

article number	S6EXP0008-292
design wavelength [nm]	532
magnification factor	0.8
divergence adjustable	yes
optical principle	Galilei (no internal focus)
pointing stability [mrad]	<1
clear input aperture [mm]	14.0
clear output aperture [mm]	20.0
recommended beam-Ø [mm]1)	6.0
total number of lenses	2
total transmission [%]	> 99
lens material	fused silica
LIDT (coating) [J/cm²]	2.5 J/cm² per 1ns pulse at 50Hz
SP and USP usable	yes
SP and USP usable, reversed usage	no
mounting thread	M30x1
weight [kg]	0.3
accessory	S6MEC0107 - adapter M30x1 to C-mount

#### **DIVERGENCE ADJUSTMENT**



#### **MOUNTING POSITIONS**



#### **REMARKS**

<sup>1)</sup>clipped at  $1/e^2$ ; wavefront error on axis (PV) <  $\lambda/10$  (value provided by design) magnification (reversed mode) = 1 / magnification (regular mode)

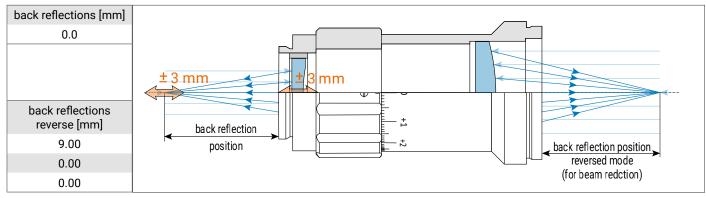
divergence adjustement = 0 → collimated input beam results in collimated output beam

maximum divergence adjustment is ± 3 mm

RoHS compliant

length at divergence setting "0" stated in the drawing - length extension of max. 3 mm is possible

#### **BACK REFLECTION POSITION**



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